



*IPU*

501.36694CV4

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Applicant(s): S. Shukuri, et al.  
Application. No. 10/635,511  
Filed: August 7, 2003  
For: SEMICONDUCTOR INTEGRATED CIRCUIT DEVICE HAVING  
DEPOSITED LAYER FOR GATE INSULATION  
Group: 2814  
Examiner: L. Pham

**AMENDMENT**

Mail Stop Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

December 6, 2004

Sir:

In response to the Office Action mailed November 5, 2004, please amend the above-identified application as listed in the following, and as set forth on the following pages:

Amendments to the Claims; and

Remarks are included following the amendments.